

Certificate of Appointment

No. UA 50054524-0019

The Applicant

**KEC Electronic Industry
Development Center
3-2-2 Hikari-dai, Seika-cho
Soraku-gun, Kyoto
619-0237 Japan**

has been authorized to carry out EMC tests
by order and under supervision of TÜV Rheinland according to

Standards of EMC appointment: see Appendix 2.4
to this certificate.

An assessment of the laboratory was conducted according to the "Procedures and
Conditions for Appointments of EMC Test Laboratories" with reference to
EN ISO/IEC 17025 by a TÜV Rheinland auditor.

Audit Report No. 09661523-026


This certificate is valid until the next scheduled audit or up to 12 months,
at the discretion of TÜV Rheinland.

Date of issue: 05.08.2024



Certification Body

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Shinichi Sakai

Certificate of Appointment

Appendix 2.4 for UA 50054524-0019, dated 05.08.2024

Standards of EMC appointment:

EN 15194, EN 50412-2-1, EN/IEC 61851-21-1, EN/IEC 61851-21-2,
EN/EN IEC/IEC 61000-6-1, EN/EN IEC/IEC 61000-6-2, EN/EN IEC/IEC 61000-6-3,
EN/EN IEC/IEC 61000-6-4, EN/IEC 61000-6-7, EN 12015, EN 12016, EN 12895,
EN ISO 14982, EN 50121-3-2, EN 50121-4, EN 50121-5, EN 50130-4,
EN 55011, CISPR 11, EN 55012, CISPR 12, EN 55014-1, CISPR 14-1,
EN 55014-2, CISPR 14-2, EN 55015, CISPR 15, EN 55025, CISPR 25,
EN 55032, CISPR 32, EN 55035, CISPR 35, EN/IEC 60601-1-2,
EN/IEC 60945, EN/EN IEC/IEC 61326-1, EN/IEC 61326-2-1, EN/IEC 61326-2-2,
EN/IEC 61326-2-6, EN/IEC 61326-3-1, EN/IEC 61547, EN/IEC 61800-3,
EN/IEC 62040-2, EN/IEC 62233, IEC 62236-3-2, IEC 62236-4, IEC 62236-5,
EN 300 328, EN 300 330, EN 300 386, EN 300 440, EN 300 422-1, EN 300 422-2,
EN 300 487, EN 301 489-1, EN 301 489-3, EN 301 489-9, EN 301 489-17,
EN 301 489-19, EN 301 893, EN 303 417,
EN/EN IEC/IEC 61000-3-2, EN/IEC 61000-3-3, EN/EN IEC/IEC 61000-3-11,
EN/IEC 61000-3-12, EN/IEC 61000-4-2, EN/EN IEC/IEC 61000-4-3,
EN/IEC 61000-4-4, EN/IEC 61000-4-5, EN/EN IEC/IEC 61000-4-6, EN/IEC 61000-4-8,
EN/IEC 61000-4-9, EN/IEC 61000-4-10, EN/EN IEC/IEC 61000-4-11,
EN/IEC 61000-4-12, EN/IEC 61000-4-13, EN/IEC 61000-4-16,
EN/EN IEC/IEC 61000-4-18, EN/IEC 61000-4-29, EN/IEC 61000-4-34,
EN/IEC 61000-4-39, ISO 7637-1, ISO 7637-2, ISO 7637-3, ISO 10605,
ISO 11451-2, ISO 11452-2, ISO 11452-3, ISO 11452-4, ECE-R10-04; ECE-R10-05,
JIS C 4411-2, EN ISO/ISO 13766-1, EN ISO/ISO 13766-2, ISO 16750-2